

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Miller et al.**

Serial No.: **Unknown**

Filed: **May 23, 2001**

For: **Method and Apparatus for
Deposition of Porous Silica Dielectrics**

§
§
§
§
§
§

Group Art Unit: **2812**

Examiner: **Luk, O.**

Attorney Docket No.: **98-197/1D**

Certificate of Mailing Under 37 C.F.R. § 1.8(a)

I hereby certify this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on May 23, 2001.

By:


Krista Douthitt

PRELIMINARY AMENDMENT

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

Prior to examination of this application, please amend the above-identified application as follows:

IN THE CLAIMS:

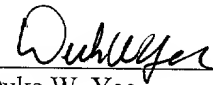
Please cancel claims 1-25.

REMARKS

Claims 1-25 have been canceled. Claims 26-29 remain in the application. These claims are believed to be in condition for allowance. The examiner is invited to call the undersigned at the below-listed telephone number if in the opinion of the examiner such a telephone conference would expedite or aid the prosecution and examination of this application.

Date: May 23, 2001

Respectfully submitted,


Duke W. Yee
Registration No. 34,285
CARSTENS YEE & CAHOON, LLP
P.O. Box 802334
Dallas, Texas 75380
(972) 367-2001
ATTORNEY FOR APPLICANT